

Docket No. F-7337

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815****RECEIVED
CENTRAL FAX CENTER****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****MAR 22 2004**

Applicant : Shigeki SAKAI, et al.
Serial No. : 10/090,851
Filed : March 4, 2002
For : SEMICONDUCTOR NONVOLATILE STORAGE
ELEMENT AND METHOD OF FABRICATING THE
SAME
Group Art Unit : 2815
Examiner : Jesse A. Fenty
Confirmation No. : 5906
Customer No. : 000028107

OFFICIAL**Certificate of Facsimile Transmission Under 37 CFR 1.8**

I hereby certify that this correspondence is being transmitted in accordance with 37 CFR §1.6(d) to the United States Patent Office addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on March 22, 2004 to facsimile no. (703) 872-9306.

TOTAL NUMBER OF PAGES TRANSMITTED: 9
PLEASE TRANSMIT ACKNOWLEDGMENT TO 212 953 7733

Herbert F. Ruschmann
(Name)


(Signature)

MAIL STOP NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Sir:

F7337 am02 (PC 10) wpd

Docket No. F-7337

Ser. No. 10/090,851

In response to the final Office Action of December 23, 2003, entry of the present amendment effecting claim amendments to place the application into condition for allowance is respectfully requested. Please amend the above-identified patent application as follows: